



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Group Art Unit: 1753

Application No.: 10/658,460

Examiner: R.G. McDonald

Filed: September 10, 2003

Attorney Docket No.: 101136-00095

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: November 16, 2006

Sir:

In reply to the May 23, 2006 Office Action, the period for response being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims; and

Remarks.